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Bib Data Sheet

CONFIRMATION NO. 1079

SERIAL NUMBER 09/994,508	FILING DATE 11/27/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. SAM-0298	
APPLICANTS Jae-Hak Kim, Seoul, KOREA, REPUBLIC OF; Hong-Jae Shin, Seoul, KOREA, REPUBLIC OF; Soo-Geun Lee, Kyunggi-do, KOREA, REPUBLIC OF; Kyoung-Woo Lee, Seoul, KOREA, REPUBLIC OF;					
** CONTINUING DATA *****					
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 2000-74836 12/08/2000 REPUBLIC OF KOREA 2001-36933 06/27/2001					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/23/2002					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u>		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 2
ADDRESS Steven M. Mills MILLS & ONELLO LLP Suite 605 Eleven Beacon Street Boston ,MA 02108					
TITLE Method of fabricating semiconductor devices having low dielectric interlayer insulation layer					
FILING FEE RECEIVED 776	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		